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ITC 2800 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Jun KANAMORI

Group Art Unit: 2814

Serial No.: 09/398,189

Examiner: S. Rao

Filed: September 17, 1999

For: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE WITH SELF-
ALIGNED SILICIDE AREAS FORMED USING A SUPPLEMENTAL SILICON
OVERLAYER

REQUEST FOR RECONSIDERATION

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Date: May 9, 2001

Sir:

In response to the Final Office Action dated February 13, 2001, the following
remarks are respectfully submitted in connection with the above-identified application.

REMARKS

Claims 1-9 and 19-22 are pending in the present application.

Information Disclosure Statements

An Information Disclosure Statement was filed along with the present application
on September 17, 1999. However, the Examiner has failed to acknowledge receipt of
the above noted Information Disclosure Statement filed on September 17, 1999. Th
Examiner is r spectfully request d to acknowledge receipt of the Informati n